



ELECTRONIC COPY

LG803638233
Report verification at igi.org



May 29, 2026

IGI Report Number **LG803638233**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **ROUND BRILLIANT**

Measurements **6.40 - 6.47 X 3.90 MM**

GRADING RESULTS

Carat Weight **1.01 CARAT**

Color Grade **E**

Clarity Grade **VS 1**

Cut Grade **EXCELLENT**

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ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**

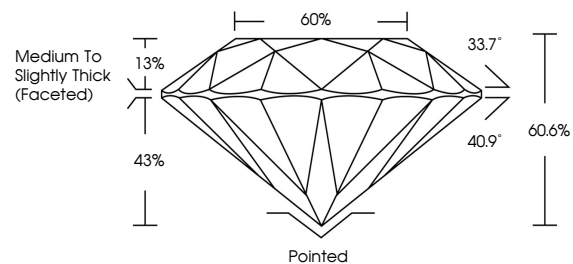
Symmetry **EXCELLENT**

Fluorescence **NONE**

Inscription(s) **IGI LG803638233**

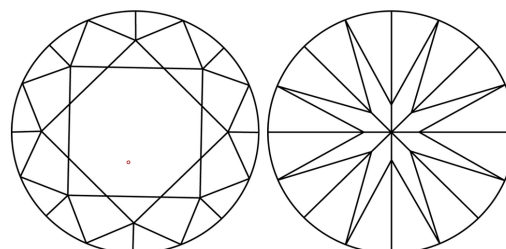
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

PROPORTIONS



Sample Image Used

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

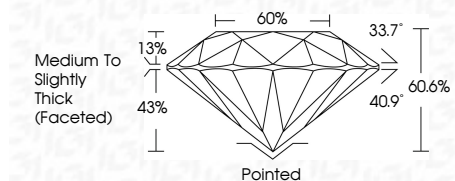
Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

COLOR

D E F G H I J Faint Very Light Light

CLARITY

FL	IF	VS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



ADDITIONAL GRADING INFORMATION

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Symmetry **EXCELLENT**

Fluorescence **NONE**

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May 29, 2026	1.01 CARAT	E	VS 1	EXCELLENT	60.6%	60%	Medium To Slightly Thick (Faceted)	Pointed	EXCELLENT	EXCELLENT	NONE	IGI LG803638233
IGI Report No. LG803638233	Carat Weight	Color Grade	Clarity Grade	Cut Grade	Depth	Table	Girdle	Culet	Polish	Symmetry	Fluorescence	Inscription(s)
ROUND BRILLIANT	6.40 - 6.47 X 3.90 MM	E	VS 1	EXCELLENT	60.6%	60%	Medium To Slightly Thick (Faceted)	Pointed	EXCELLENT	EXCELLENT	NONE	IGI LG803638233

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